

High Energy Density Physics (HEDP) Capabilities at the Linac Coherent Light Source (LCLS)

Phil Heimann (SLAC)

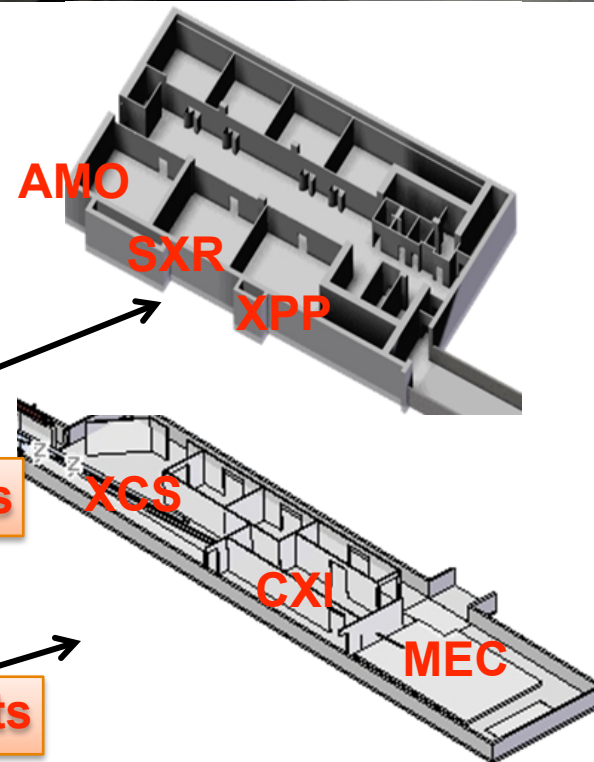
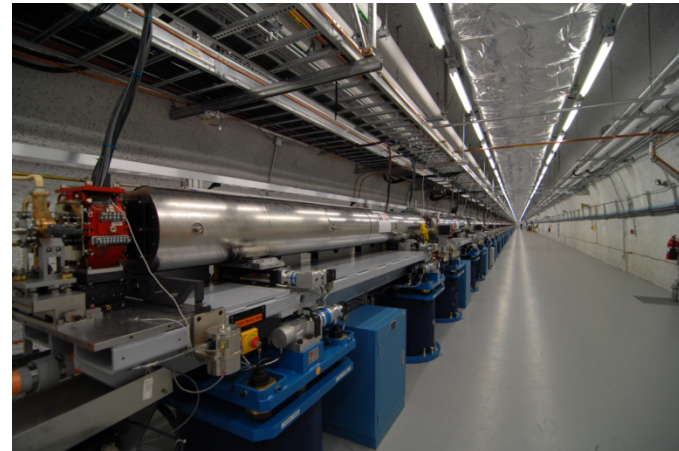
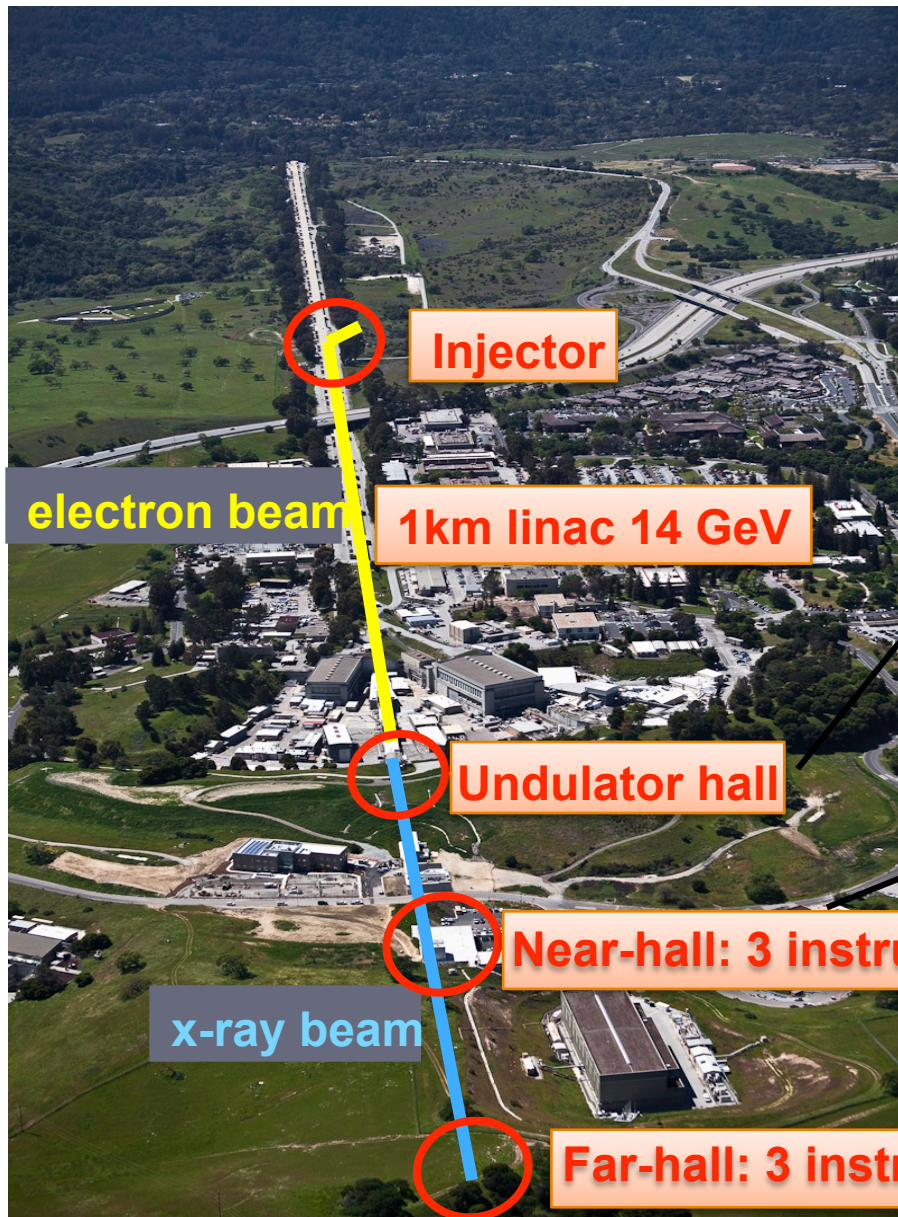
Hae Ja Lee, Bob Nagler, Richard M Boyce, Lori Plummer, Jerry Hastings (SLAC)
and Dick Lee (LBNL)

January 22, 2013



- An introduction to the LCLS Free Electron Laser facility.
- The capabilities of the LCLS MEC instrument.
- Summary

Linac Coherent Light Source (LCLS)

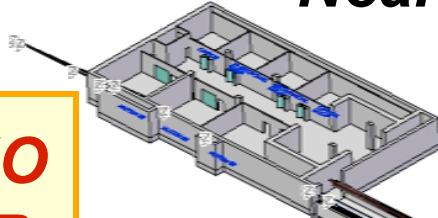


Experimental Halls and Operations Schedules

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Near Experimental Hall

AMO
SXR
XPP

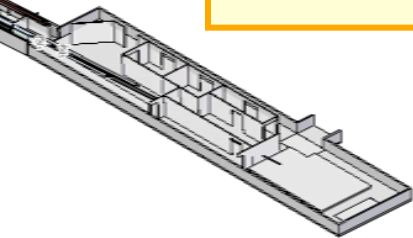


X-ray Transport Tunnel
200 m

	Start of operation
AMO	Oct-09
SXR	May-10
XPP	October-10
CXI	February-11
XCS	November-11
MEC	April-12

XCS
CXI
MEC

Far Experimental Hall



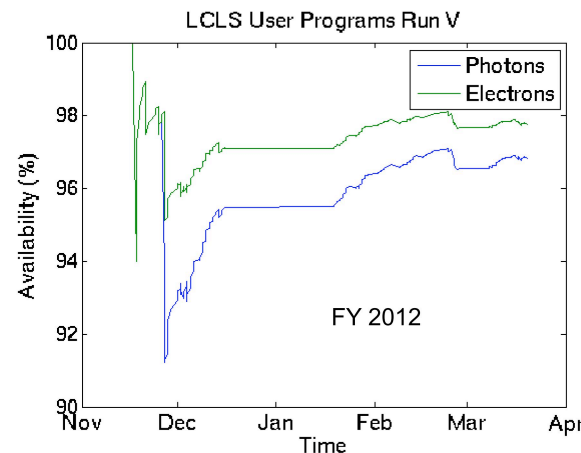
AMO: Atomic, Molecular and Optical
SXR: Soft X-Ray materials sciences
XPP: X-ray Pump-Probe

XCS: X-ray Correlation Spectroscopy
CXI: Coherent X-ray Imaging
MEC: Materials under Extreme Conditions

LCLS Machine Performance

SLAC

	Baseline performance	Current performance
Photon energy range	830 to 8300 eV	480 to 10,000 eV
FEL pulse length	230 fs	5 - 500 fs
FEL pulse energy	up to 2 mJ	up to 4 mJ



95% photon availability

LCLS produces x-rays with high peak intensity (photons/fs).  X-rays either (i) Make HED matter or (ii) Probe HED states prepared by optical lasers.

LCLS Proposal Process



- Proposal deadlines ~ every 6 months, last January 15
- Format: experimental team, scientific case, experimental procedure.
- Proposal Review Panel: includes a High Energy Density Science subpanel.
- ~ 25 % of proposals receive beamtime.
- Independent process for LCLS instrument scientists to submit proposals for a fraction of the beamtime.

LCLS Run 7 Schedule



Jan 13	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31			
	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu			
Day							Accelerator Start-Up								IH			IH			L746 Nilsson						L648 Doniach			IH		IH		
Night															Photon Start-Up			IH-Sci Lemke1									Comm							

Feb 13	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	
	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	
Day	L684 Doumy						Photon MD			Ph. MD				L702 Gray								L723 Lee						L733	
Night	L662 Bressler		IH			IH	L767 Seeman							L675 Coffee									L772 Staub						L785

Mar 13	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31	
	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	
Day	L733 McMahon						IH-Sci Lemke2						IH-Sci Messerschmidt								L766 Schuessler-L						L666 Cammarata					
Night	L785 Yachandra						IH-Sci Coffe					IH	IH		L728 Mack					Det			L672 Cherezov						L649 Rudenko			

Apr 13	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30
	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue
Day				L780 Wark							L659 Bogan							L722 Lee							L700 Glenzer					
Night				L677 Collet							IH-Sci Nagler							IH-Com GMD							L637 David					

May 13	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31
	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri
Day	L691 Frank						L710 Hill						L755 Ravasio						IH-Com Bozek						L660						
Night	IH Det		Dia		IH-Dev Moeller						Det		L730 Maia						L731 Mankowsky						L729						

Jun 13	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	
	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	
Day	L660		IH			L748 Orville						L711 Hogue				Feng				L742 Murphy					IH-Sci Turner			IH	IH	IH	
Night	L729 Madsen					L657 Beye						L708 Hastings								L650 Soltis				IH Feng			L669 Chapman				Feng

Jul 13	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31
	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed	Thu	Fri	Sat	Sun	Mon	Tue	Wed
Day	IH			L639			IH-Sci Minitti				L695 Gaffney																				
Night	Feng			L751 Petrovic							L764 Schlichting																				

AMO

SXR

XPP

XCS

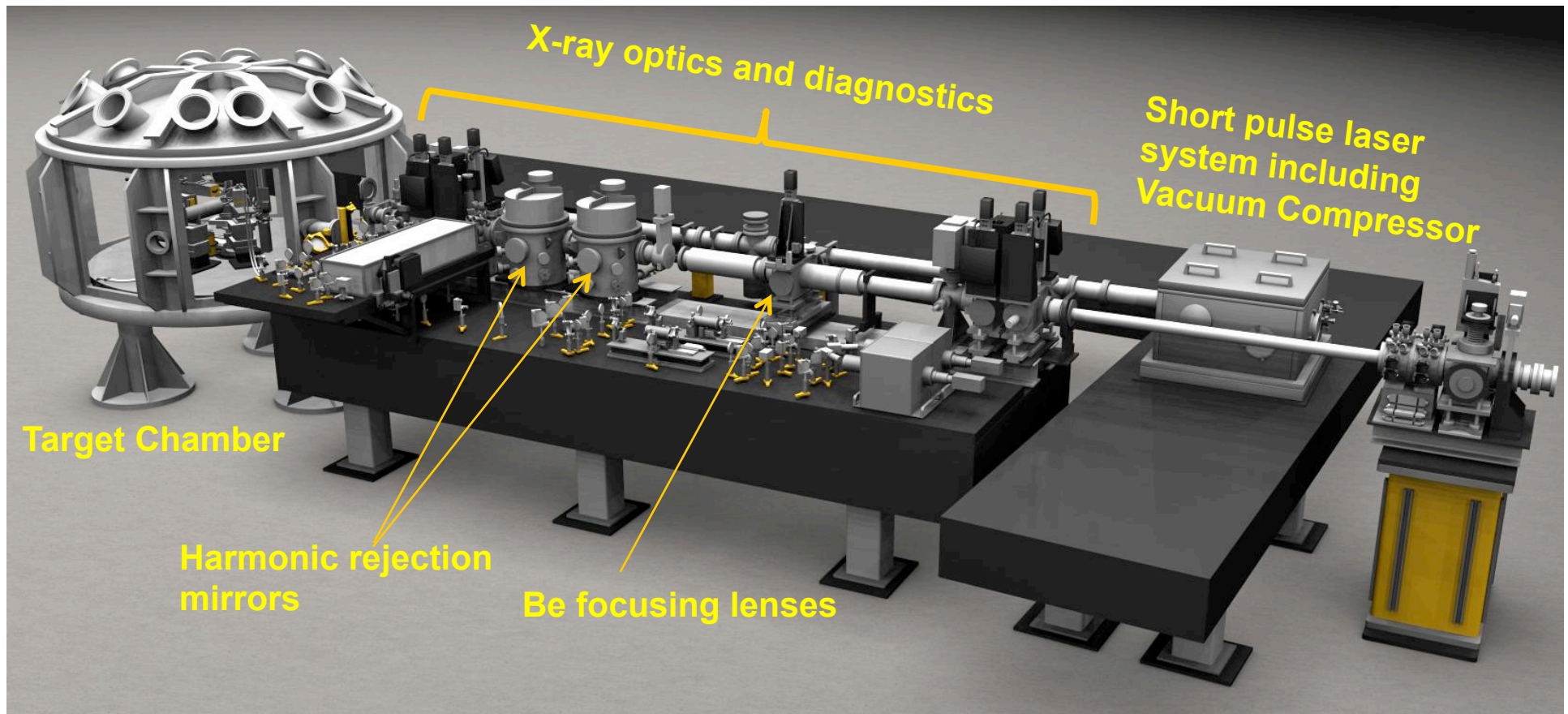
CXI

MEC

Day	9 am - 9 pm
Night	9 pm - 9 am

LCLS Materials under Extreme Conditions (MEC) Instrument

SLAC

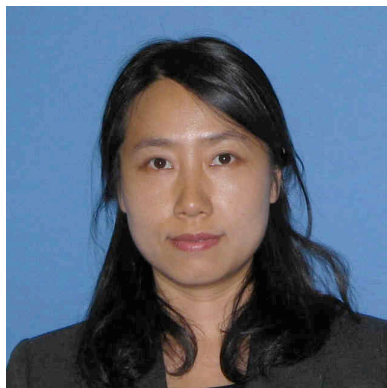


- MEC commissioning began at the end of January 2012.
- First user experiment at MEC April 2012 (very aggressive).

MEC Instrument Team



Phil Heimann
Department Lead



Hae Ja Lee
Instrument Scientist



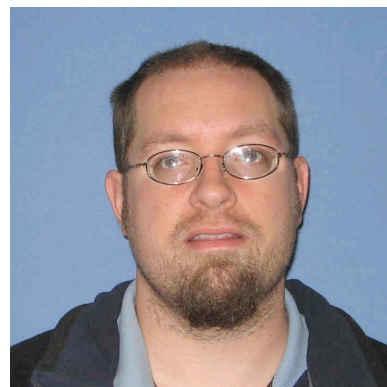
Bob Nagler
Instrument Scientist



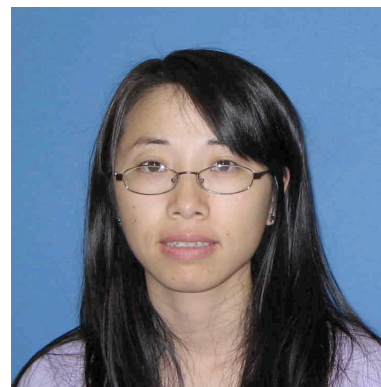
Eric Galtier
Research Associate



Marc Welch
Laser Engineer



Brice Arnold
Instrument Engineer



Jing Yin
Controls,DAQ Engineer



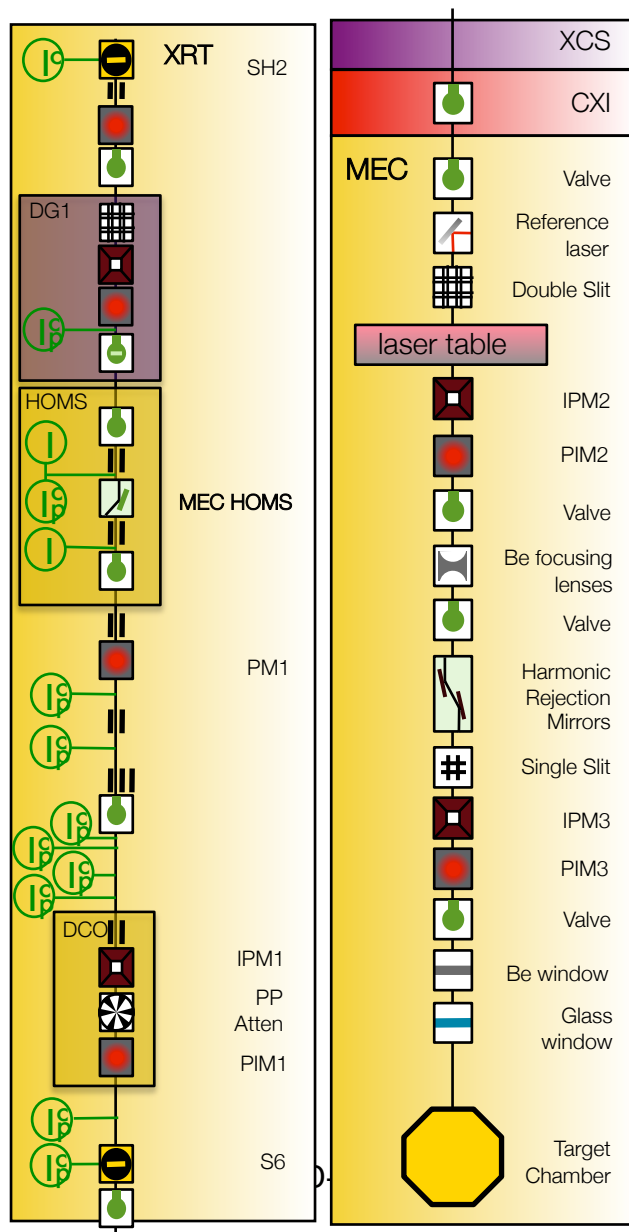
Ruben Curiel
Area Manager

MEC Provides Strong User Support



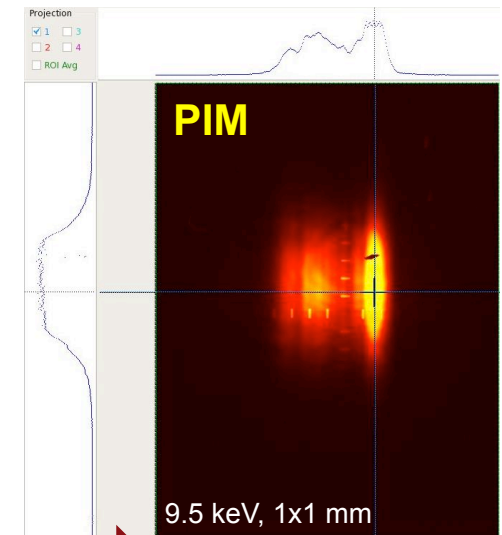
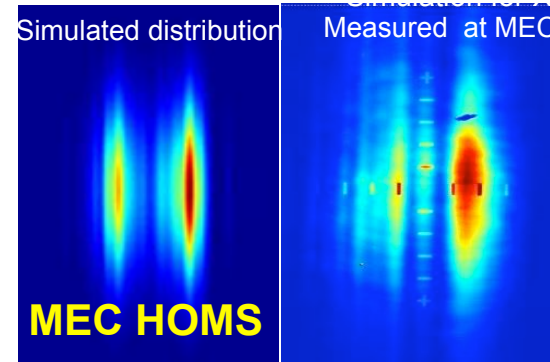
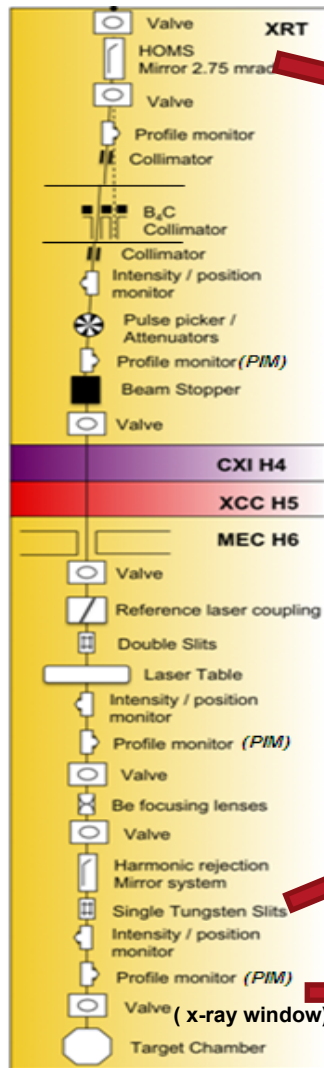
- Telephone meetings take place regularly before the beamtimes.
- MEC is responsible for a large fraction of the experimental setup, which changes significantly for each beamtime.
- There is a minimum of 1 week setup time before the beamtime.
- At least 1 instrument scientist or research associate is present throughout the beamtime.
 - Necessary because of the short beamtimes: 5 shifts of 12 hours.

MEC X-ray Optics and Diagnostics



Requirement	Device
Steer the beam to MEC	MEC HOMS mirror
Monitor the beam steering to MEC	Profile Monitor (PM)
Characterize X-ray pulse intensity	Intensity Position Monitor (IPM)
Characterize X-ray spatial profile	Profile Intensity Monitor (PIM)
Tailor X-ray intensity and spectrum	Attenuators
Tailor X-ray repetition rate	Pulse Picker
Offline Alignment	Reference Laser
Tailor X-ray spatial profile ($> 50 \mu\text{m}$)	Slit system
Tailor X-ray spatial profile ($1 \sim 50 \mu\text{m}$)	Be Focusing Lenses
Tailor X-ray spectrum	Harmonic Rejection Mirrors
Allow X-ray beam into target chamber	Be window
Allow reference optical laser into target chamber	Glass window
Provide environment for experiment	Target chamber
Create high pressure or WDM status	MEC Laser Systems
Measure the spectrum and phase	Target Diagnostics

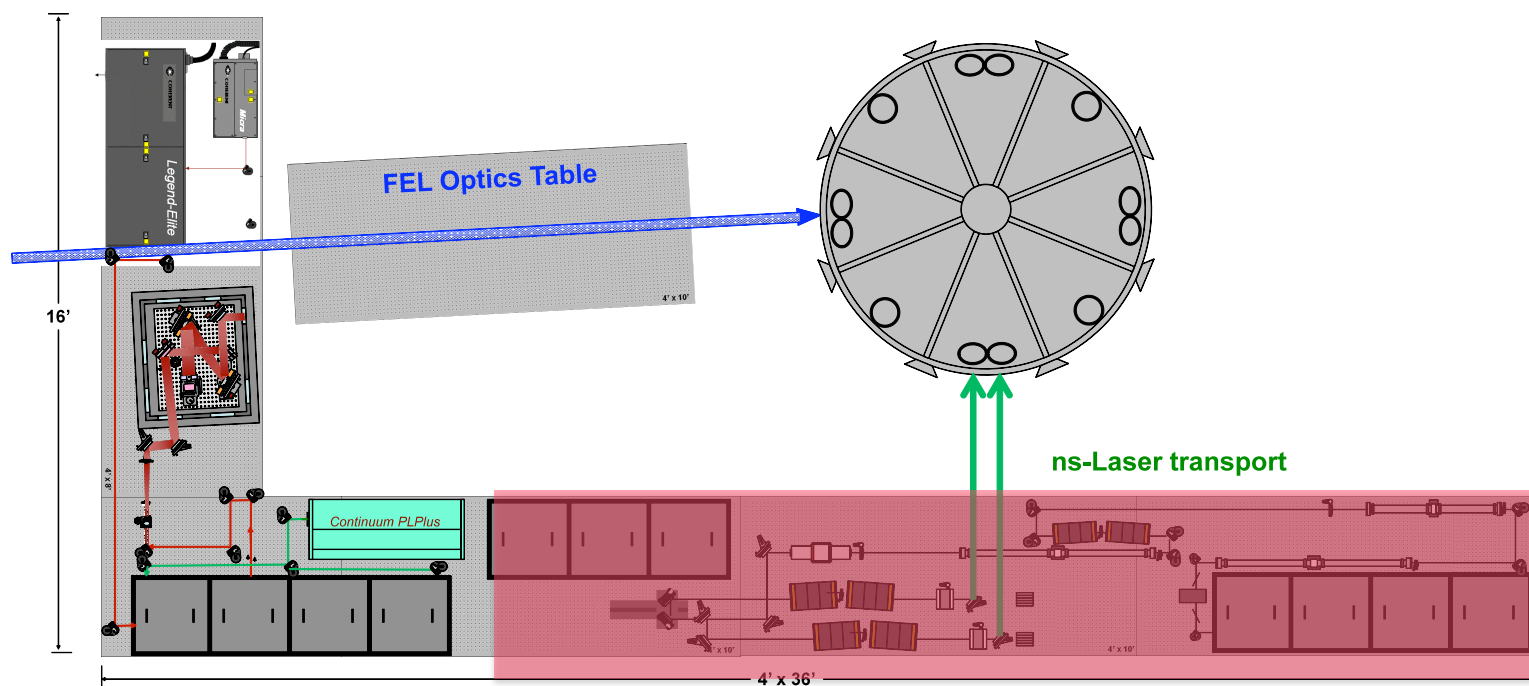
MEC X-ray Commissioning



- MEC is a hard x-ray instrument: 2–10 keV photon energy.
- Soft x-ray HEDP experiments have been done at the AMO and SXR instruments.

Long pulse laser system

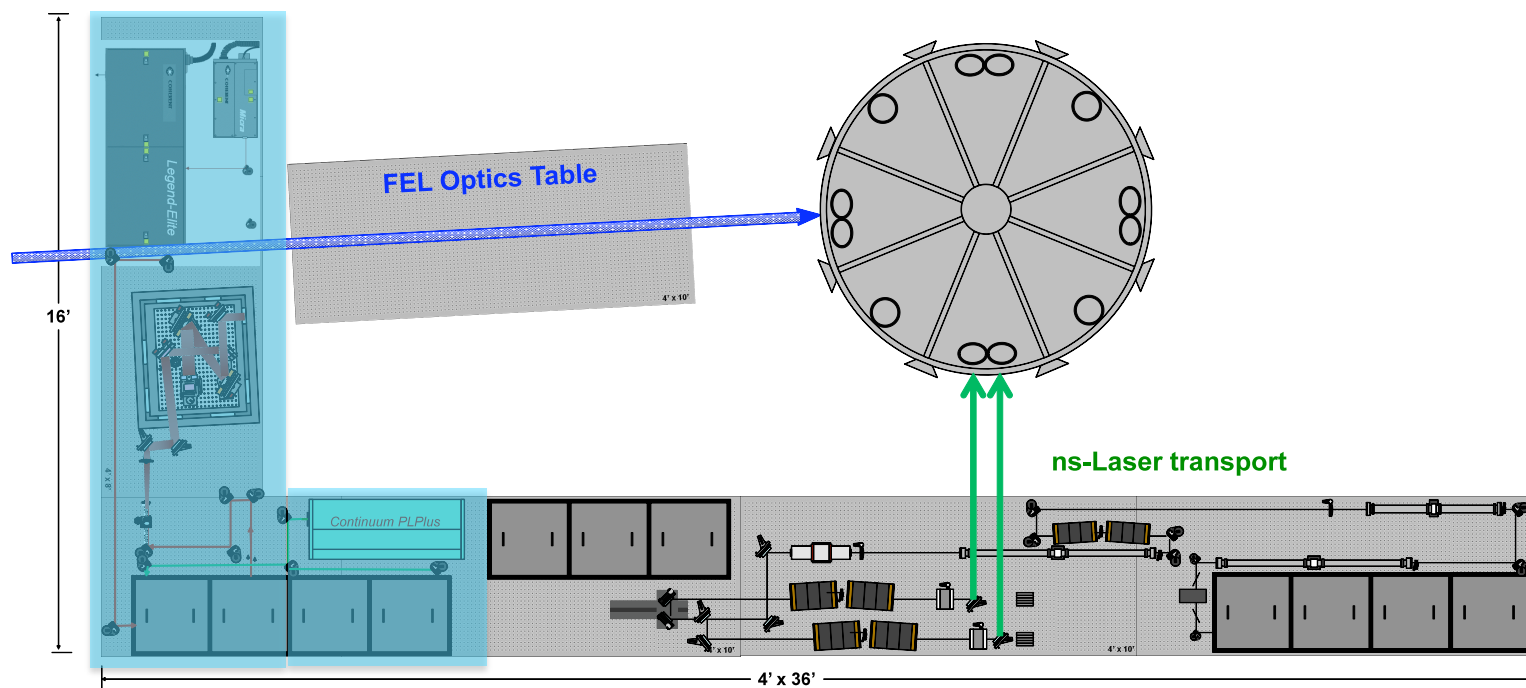
- Generates high pressure states



Long Pulse Laser	
Wavelength	527 nm
Pulse Width	2-200 ns
Repetition Rate	1 shot per 10 minutes
Pulse Energy	2 x 15 Joules

Short pulse laser system

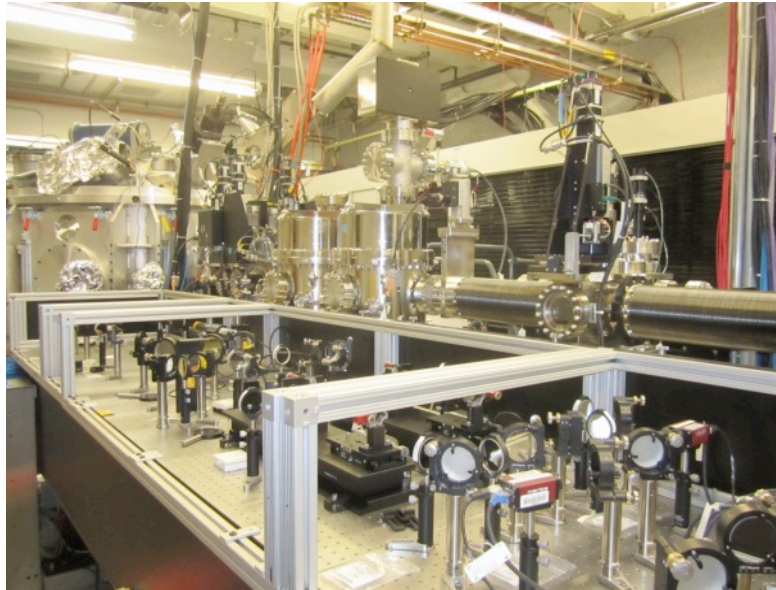
- Heating at constant density



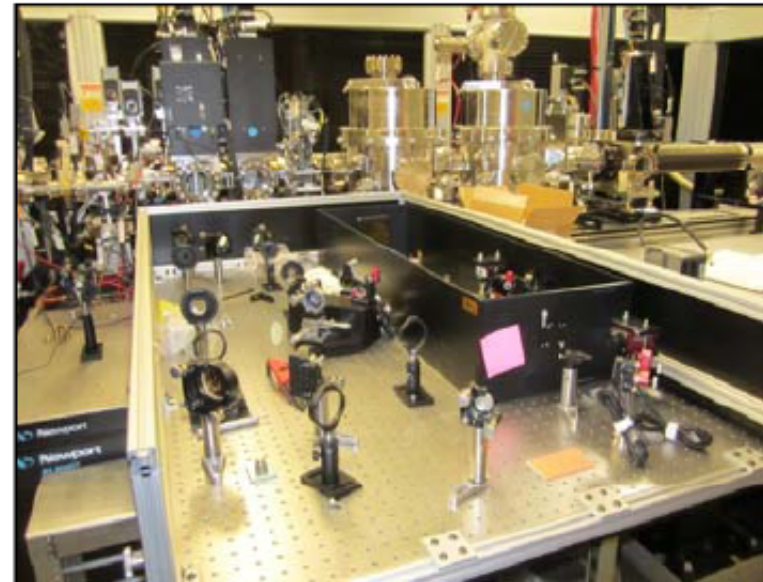
Short Pulse Laser	
Wavelength	800 nm
Pulse Width	35 fs
Repetition Rate	10 Hz
Pulse Energy	120 mJ

MEC Target Diagnostics: VISAR, FDI

Velocity Interferometer System for Any Reflector (VISAR)



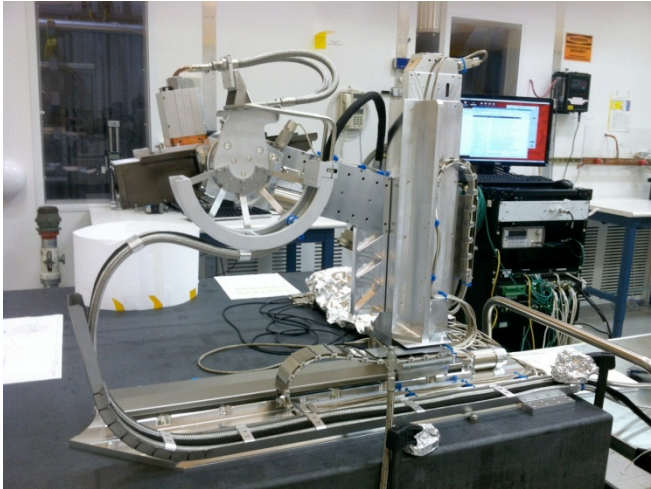
Fourier Domain Interferometer (FDI)



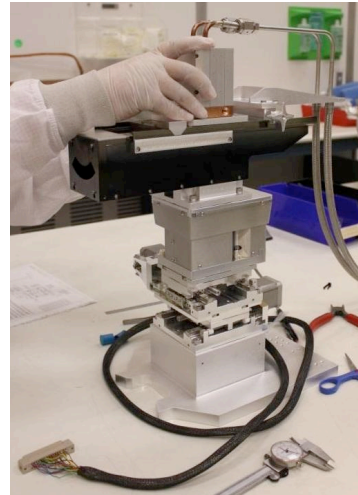
<i>Item</i>	<i>Purpose</i>	<i>Specification</i>
<i>VISAR</i>	<i>Measure shock velocity</i>	<i>Nanosecond time scale $5 \times 10^4 \sim 5 \times 10^6$ cm/s</i>
<i>Fourier Domain Interferometer (FDI)</i>	<i>Measure surface motion</i>	<i>Accurate to $\lambda/100$ for 800 nm probe</i>

MEC Target Diagnostics: XRTS, XUV

**Forward Scattering
X-ray spectrometer**



**Backward Scattering
X-ray spectrometer**



XUV spectrometer



<i>Item</i>	<i>Purpose</i>	<i>Specification</i>
<i>X-ray Scattering Spectrometer (XRTS)</i>	<i>Measure electron density and temperature</i> <i>Forward XRTS: automatic change of scattering angle, $0^\circ < \theta_s < 90^\circ$</i>	<i>Spectral resolution of $\Delta E/E \sim 4 \times 10^{-3}$ at 8 keV</i> <i>temperature (1 ~ 100 eV)</i>
<i>XUV spectroscopy</i>	<i>Measure electron temperature and study electronic band structures</i>	<i>Spectral resolving power of $\lambda/\Delta\lambda \sim 300$ at 21 nm</i> <i>temperature (0.1 ~ 50 eV)</i>

- The LCLS is the first hard x-ray FEL.
 - It began operations in 2009.
- LCLS MEC instrument has been in operation since April 2012.
 - X-ray optics and diagnostics
 - Long and short pulse laser systems
 - Target diagnostics
- HEDP experiments at LCLS (Bob Nagler tomorrow).

End of Presentation



- Soft x-ray self-seeding
 - LBNL: Mechanical engineering
 - PSI: X-ray optics
- LCLS-II
 - LBNL: Undulators